

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s) : Franz LAERMER  
Serial No. : 10/519,724  
Filed : December 28, 2004  
For : DEVICE AND METHOD FOR THE PRODUCTION OF  
CHLORINE TRIFLUORIDE AND SYSTEM FOR  
ETCHING SEMICONDUCTOR SUBSTRATES USING  
THIS DEVICE  
Examiner : Rakesh Dhingra  
Art Unit : 1716  
Confirmation No. : 5180

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is electronically transmitted to the USPTO via the Office of electronic filing system on: Date: September 3, 2010

Signature: /Kevin Kambo/  
Kevin Kambo

**REPLY UNDER 37 C.F.R. § 1.116**

S I R:

In response to the Office Action of June 3, 2010, for which the three-month period of response expires on September 3, 2010, kindly amend the above-captioned application without prejudice as follows:

Amendments to the claims are not presented in this paper. Nevertheless, a **Listing of Claims** begins on page 2 of this paper for the convenience of the Office.

**Remarks** begin on page 6 of this paper.

While no fees are believed to be due, the Commissioner is authorized, as appropriate and/or necessary, to charge any fees or credit any overpayment to **Deposit Account No. 11-0600**.